

SDC

FabVista™ Network Monitoring System



Monitoring hazardous gases is highly complex, yet critical to semiconductor and solar panel manufacturing. With much equipment to monitor and not enough employees to do so in a time and cost-effective manner. Combined with different types of equipment and technologies, makes it difficult to manage. To safely and properly manage your gas resources, FabVista™ is your complete, flexible, platform, ideally suited for gas monitoring in these industries. Incorporate a wide range of technologies and protocols to interface with many gas cabinets, boxes and panels and other gas-related equipment controllers, no matter how many types of equipment you have, it is flexible enough to manage them all.

Data collection can vary in many ways. It is determined by your needs. Typical data includes valve states, transducer pressure, eight values, system input state, alarm flags and system flags. FabVista™ can support a wide variety of protocols from a number of manufacturers as needed, in order to get the required data from your equipment. If FabVista™ doesn't currently support a given piece of equipment, the interface to support can simply be developed.

From maintaining a delivery history log for each gas source to monitoring each piece of equipment's alarms as all data is logged and archived for your review, FabVista™ assists you in getting the specific information you require for a safe lab/fab environment.

Options Include:

- Alarm Management
- TXT / email alerts
- Material consumption monitoring

SDC provides safe solutions to meet your hazardous gas detection needs. FabVista™....your successful safety monitoring solution to protect the people, equipment and facilities at your company.



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